FORM PTO-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	Complete if Known	
		Application Number	Unknown
	INFORMATION DISCLOSURE STATEMENT BY APPLICANT	Filing Date	October 10, 2003
		First Named Inventor	Easter, et al.
		Group Art Unit	Unknown
		Examiner Name	Unknown
Sheet 1 of 1		Attorney Docket Number	27757-901

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Examiner Initials		Document Number	Date	Name	Class	Sub-Class	Filing Date
	AA	6,276,998 B1	8/21/01	Sommer, et al.			
	AB	6,264,540 B1	7/24/01	Fruitman			
	AC	6,121,143	9/19/00	Messner, et al.			
	AD	5,691,372	11/25/97	Tung, et al.			
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	AZ	Steigerwald, et al., "Chemical Mechanical Planarization-An Introduction," *Chemical Mechanical Planarization of Microelectronic Materials Textbook*, pages 1-81 (1997).
	BA	Nishi, et al., "Chemical-Mechanical Polish," *Handbook of Semiconductor Manufacturing Technology*, pages 419-432 (2000).

Examiner Signature		Date Considered	8/16/05

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.